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CONFIRMATION NO. 1842

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SERIAL NUMBER	FILING OR 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/578,398	05/04/2006	430	1795	SHIGA7.049APC
RULE				

## APPLICANTS

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## \* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP04/17534 11/18/2004

## \* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-401563 12/01/2003  
 JAPAN 2004-265693 09/13/2004

## F REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

11/27/2007

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
5 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	0	6	1
Verified and Acknowledged	Examiner's Signature <u>du Chateau</u> Initials				

## ADDRESS

0995

## TITLE

Thick film photoresist composition and method of forming resist pattern

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